## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: Q83944 Hiroto OHTAKE, et al. Group Art Unit: 2818 Appln. No.: 10/509,898 Examiner: Hoang Quan Tran HO Confirmation No.: 2975 Filed: October 1, 2004 SEMICONDUCTOR DEVICE AND ITS MANUFACTURING METHOD For: AMENDMENT UNDER 37 C.F.R. § 1.111 MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 Sir: In response to the Office Action dated June 27, 2007, please amend the above-identified application as follows on the accompanying pages. TABLE OF CONTENTS AMENDMENTS TO THE CLAIMS......2 REMARKS.......7